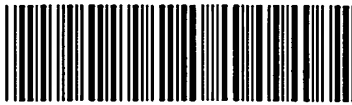


**Search Notes**

Application/Control No.

10/803,696

Examiner

Paulos M. Natnael

Applicant(s)/Patent under  
Reexamination

KIM, MIN-HO

Art Unit

2622

**SEARCHED**

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**SEARCH NOTES  
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